

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kevin J. Orvek
Serial No. : 10/814,883
Filed : March 31, 2004

Art Unit : 2823
Examiner : Jarrett J. Stark
Confirmation No: 7571

Title : REAL-TIME MONITORING OF PARTICLES IN SEMICONDUCTOR
VACUUM ENVIRONMENT

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO FINAL ACTION OF JULY 12, 2006

Please amend the above-identified application as follows: